The Diamond Machine Protection System

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Abstract

The Diamond Light Source Machine Protection System manages the hazards from high power photon beams and other hazards to ensure equipment protection on the booster synchrotron and storage ring. The system has a shutdown requirement, on a beam mis-steer of under 1 msec and has to manage in excess of a thousand interlocks. This is realised using a combination of bespoke hardware and programmable logic controllers. The structure of the Machine Protection System will be described, together with operational experience and developments to provide post-mortem functionality.

Photon Beamline Protection is realised by PLC's to manage interlocks from vacuum faults, temperature sensors and flowmeters to generate permits which allow front ends to open. Most beamline faults are managed by simply shutting the front end. A few faults on beamlines result in the Machine Protection system having to dump the stored Beam. All new Beamlines undergo a design process to ensure that they are self sufficient in terms of protections allowing reliable shutdown without to dump the stored beam.

~150 microseconds

System Specification

The most critical interlocks are the **position limits** for the stored beam generated by the Libera Beam Position Monitors (BPMs). The total BPM response time is the sum of:-~200 microseconds BPM detection delay Delay between BPM output to local MPS module to Global vessel ~250 microseconds permit Delay through RF amplifier and cavity to dumping of beam.

Beam position error Beam position monitor Global vessel permit output RF field to zero Circulating beam ~600µsec delay



Plant sensors include:- Thermostats, PT100's, Flow meters, Valve position limit switches, Vacuum Gauge level set-points, Beam position Sensors, Beam Stability Sensors and Front End & Beamline Healthy (Beamline masked by Front End).

The EPICS Interface

An EPICS driver communicates with the MPS card via a Hytec 8001 64-bit digital I/O board with modified firmware.

This allows the reading of the state of the 32 inputs and jumpers directly and previously unused bits in the 8001's control and status register indicate the interlock state providing the means to generate a reset signal. An overview of the system is presented to the operator showing the status of the global permits. Further information is available from the LMPS via the IOC. It is possible to see the status of each individual input on a PLC via the serial link between the PLC and the IOC.



	MPS Overv	/iew	
	Machine F	Protection	
– Booster Ring	1 —	1 2	3 4
Dipole D-Quad F-Quad Vessel	ActiveResetActiveResetActiveResetActiveReset	Dipole Magnets D-Quad Magnets D-Quad Magnets F-Quad Magnets Vessel Cavity PL	
– Storage Ring	J		
Vessel	Active Reset Active Reset Active Reset	 RF Permit 1 RF Permit 2 RF Permit 3 Vessel Int 	Vessel erlocks
Vessel Reset	Full Reset	Dipole Permit Dipole Inte	erlocks
Vessel Dipole			11 12
Vessel Dipole			
Water Flow	s Jumper Mask	Temp Change	
CIA Temps	Tunnel Temps	VME Temps PLC Te	mps
BR 🔳 56.6 C	BR vxStats SR	67.6 C SR vxStats	Close
	PLC Interlocks	01	I

Photon Beamline Protection

Beamline protection is managed using RIO capable DLS Valve controllers. The controller provides the EPICS interface to the Beamline Vacuum system and traditional coolant plant protection via an Ethernet connection. The system offers local interfacing and interlock connectivity to the MKS 937B Gauge controllers, Fast Vacuum Valve controllers, MPC's, Pneumatic devices, Motion Control systems, Cryo plant and PSS devices as well as remote IO connection for thermal sensors and flow indicators, Motion over travel limits and RGA equipment.





		Girder 1 Primary EBPM	EBPM12	50	60 C	19.2		Girder 2 Crotch Flow	CWATR-20		Girder 2 Quad	
		Girder 2 X-Ray Leg End 1	XRAY21	50	- 50 C	18.9		Girder 3 Vessel Flow	VWATR-30		Girder 2 Sext	
		Girder 2 X-Ray Leg End 2	XRAY22	50	60 C			Girder 3 Beam Port Flow	BWATR-30		Girder 3 Quad	
		Girder 2 BPM Body	EBPM21	50		20.0		Girder 3 Crotch Flow	CWATR-30		Girder 3 Sext	
		Girder 3 EBPM Body	EBPM31	50	60 C	19.3		ID Flow				
T		Girder 3 Primary EBPM	EBPM32	50	- 50 C	20.1						
		Girder 3 Incoming Flange	FLNGE32		- 50 C	19.2						
		Girder 3 Valve Flange	FLNGE	50	- 50 C	19.6						
Г	- Dipole Te	mp Interlocks	-	Setpoint -	- Read -	- Temp -	Vessel I	Flow Interlocks			oole Flow Interlocks -	$\neg \parallel$
		Girder 2 Crotch Absorber	CWATR21	50	- 50 C	18.6	Reset	Normal Drop		Norn		2
		Girder 3 Crotch Absorber	CWATR31	50	- 60 C	18.6		Temp Interlocks				┛║
	- Water Flow	w Delay					Reset	Normal Drop		[Parent Close	

The PLC screen allows the operator to change the thermal trip points and add filtering to water interlock inputs to allow dips in water flow to be ignored. It also features a Beam trip test button which allows for automated testing of each sector of the MPS after a shutdown.

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Vessel Ter

system.







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